



Docket No. 0524-0139.02

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Application of:

Nozawa et al.

Serial No.: 10/821,508

Filed: April 9, 2004

For: Manufacturing Method And Apparatus of  
Phase Mask Shift Blank

Examiner: Steven Versteeg

Art Unit: 1753

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Shannon Wallace

Date: November 2 2004

**AMENDMENT B**

Commissioner of Patents  
P. O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

In response to the Office Action of July 28, 2004, a one month extension of time being  
submitted herewith, please amend the above-identified application as follows: